

Substitute for form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number	740819-1016 10/600,596
		Filing Date	June 23, 2003
		First Named Inventor	Satoshi SHIBATA et al.
		An Unit	2859
		Examiner Name	S. Pruchnic
		Attorney Docket Number	740819-1016
Sheet	1	of	1

U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
508 ↓ 508		US-6,132,081	10/17/2000	Han	CLASS/508
		US-6,022,749	02/08/2000	Davis et al.	- / -
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		Country Code ³ Number ⁴ (if known)				
508		WO 98/57146 A1	12/17/1998		CLASS/508	Abstract

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
508		Fried, M., et al., "Optical properties of thermally stabilized ion implantation amorphized silicon," Nuclear Instruments and Methods in Physics Research, B19/20, North-Holland, Amsterdam (1987) 577-581.	
508		Csepregi, L., et al., "Reordering of amorphous layers of Si implanted with 31P and 75As, and 11B ions," Journal of Applied Physics (Oct. 1977) Vol. 48, No. 10, pp. 4234-40.	

Examiner Signature	<i>Stanley Pruchnic</i>	Date Considered	3/2/04
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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